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MAR 31 2005
TRADE MARK OFFICE
In re

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KIYOFUMI SAKAGUCHI, ET AL.

Application No.: 10/085,046

Filed: March 1, 2002

For: PROCESS FOR PRODUCTION OF
SEMICONDUCTOR SUBSTRATE

Examiner: G. Fourson, III

Group Art Unit: 2823

March 28, 2005

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated January 26, 2005, reconsideration of the subject application is respectfully requested in view of the following amendments and remarks:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on _____, _____, _____.

March 28, 2005

(Date of Deposit)

Robert H. Fischer

(Name of Attorney for Applicant)

(Name of Attorney)

Robert G. Fischer

Signature

May. 28 2005

Date of Signature